UNITED STATES PATENT APPLICATION

FOR

A PARTIALLY DISTRIBUTED CONTROL MECHANISM FOR SCANOUT INCORPORATING FLEXIBLE DEBUG TRIGGERING

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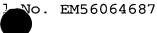**MUKHERJEE, Aditya**

A PARTIALLY DISTRIBUTED CONTROL MECHANISM FOR SCANOUT INCORPORATING FLEXIBLE DEBUG TRIGGERING

This application is a continuation-in-part of U.S. patent application serial no. 09/677,392 filed September 29, 2000.

BACKGROUND OF THE INVENTION

1. Field of the Invention

The invention relates to error detection/correction and fault detection/recovery. More particularly, the invention relates to digital logic testing through a reduction in the number of global test control lines.

2. Background Information

An integrated circuit or "chip" is a microelectronic semiconductor device having many interconnected transistors and other components. Chips may be fabricated on a small rectangle cut from a silicon wafer. The small size of these circuits allows high speed, low power dissipation, and reduced manufacturing cost compared with board-level integration.

The first integrated circuits contained only a few transistors. Small Scale Integration (SSI) brought circuits containing transistors numbered in the tens. Later, Medium Scale Integration (MSI) contained hundreds of transistors and Large Scale Integration (LSI) contained thousands of transistors. At present Very Large Scale Integration (VLSI) circuit chips are composed of hundreds of thousands of logic

elements or memory cells. Digital VLSI integrated circuits

may contain anything from one to millions of logic gates -

inverters, gates, flip-flops, and multiplexors on a few

square millimeters.

5   Part of producing a scaleable VLSI chip includes testing

and debugging the chip. Debugging is an attempt to determine

the cause of any malfunction symptoms detected by testing.

Circuitry may be built into an integrated circuit to assist

in the test, maintenance, and support of an assembled

10   circuit. Hardware features, known as design for test (DFT)

features or resources, may be incorporated into a chip to aid

in testing and debugging.

Determining the cause of a malfunction or other problem

may be achieved by using a testing machine to send a

15   simulated signal from a debug pin residing on the perimeter

of the chip to a logic element within the chip so as to

trigger a response bit (0 or 1) from that logic element. On

a clock signal, an instruction may cause a snapshot or "scan"

to be taken of this triggered response bit by a DFT feature.

20   On the next clock signal, and as part of that same

instruction, the scan information bit may be shifted one bit

"out" towards a serial output on the ~~output the~~ chip to a second perimeter

pin so that the scan bit may be compared to an expected

response. If this triggered response or "scanout" varies

25   from the expected response, then that particular logic

element may be a cause of the noted problem.

Note, to ~~To adequately~~ debug a chip, it may be necessary to view

a sampled state of hundreds of chip-internal signals within a

space of minutes. Conventionally, ~~a first~~ for example, a first debugging

technique may be used to isolate a probable bug location from

a million transistors to a group of a few hundred

transistors. Then, a second debugging technique may be used

5   to rapidly find the exact transistor failure point from the

grouped few hundred transistors. Chips may have redundant

transistors in them such that, once a transistor failure

point is located, the transistor may be turned off as part of

chip production while a redundant transistor may then

10   similarly be turned on.

~~To isolate~~ For example, to isolate a probable bug location from a million

transistors to a group of a few hundred transistors, an

integrated circuit chip may be designed to include internal

read-only test points. These test points (or scanout

15   "cells") generally are scattered throughout the integrated

circuit chip. When chained together to form a distributed

shift register, scanout cells produce parallel data that

provides observability of selected nodes during functional

testing during normal operation of the chip.

20   U.S. patent 5,253,255 teaches a centralized control

mechanism that employs two global test control lines for each

design for test (DFT) feature. ~~Here,~~ According to the patent, sequentially activating

the snapshot and the shift with signals requires two global

speed critical signals that require close timing tolerances

25   between the two signals.

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BRIEF DESCRIPTION OF THE DRAWINGS

The invention is illustrated by way of example and not by way of limitation in the figures of the accompanying

5   drawings in which like references indicate similar elements. It should be noted that references to "an" or "one" embodiment in this disclosure are not necessarily to the same embodiment, and such references mean at least one.

Figure 1 illustrates platform 100 ~~of the invention~~ *of an embodiment of the invention*

10   having chip 102 disposed on support structure 104;

Figure 2 illustrates chip 200;

Figure 3 illustrates chip 300 as a conventional modification of chip 200 of **Figure 2**; and

Figure 4 illustrates chip 400 ~~of the invention~~ *of an embodiment of the invention*.

15   **Figure 5** illustrates a global and local view of scanout control in an embodiment of the invention.

Figure 6 illustrates logic equations and details of control line signals of an embodiment of the invention.

Figure 7 illustrates scanout clock waveforms for

20   shifting a scanout chain.

Figure 8 illustrates scanout clock waveforms for a snapshot on an external trigger.

DETAILED DESCRIPTION OF THE INVENTION

Figure 1 illustrates platform 100 of the invention having chip 102 disposed on support structure 104. Platform

5   100 may be any structure having electronic components, such as chip 102. For example, platform 100 may be a computer or computer system. Moreover, platform 100 may be a printed circuit board (PCB). By way of background, a computer or other electronic system might be built from several PCBs,

10   such as processor, memory, graphics controller, and disk controller *PCBs.* These boards might all plug into a motherboard or backplane or be connected by a ribbon cable.

Chip 102 may be referred to as a processor or integrated circuit and may be thought of as a microelectronic

15   semiconductor device having many interconnected transistors and other components. Platform 100 may also include memory controller 106, Peripheral Component Interconnect (PCI) bridge 108, and chip 110, each communicatively coupled through processor bus 112.

20   Memory controller 106 may be coupled to memory chips 114. A controller may be thought of as that part of platform 100 that allows platform 100 to use certain kinds of devices. Thus, memory controller 106 may be thought of as that part of platform 100 that allows platform 100 to use memory chips

25   114. Memory chips 114 may be any device that can hold data in machine-readable format.

PCI is a standard to connect external or peripheral devices to a personal computer. The PCI standard entitled

PCI to PCI Bridge Architecture Specification (Rev. 1.1, PCI

Special Interest Group, Portland, Oregon, 1998) may be

implemented in a mezzanine or a bridge, such as PCI bridge

108. Here, PCI bridge 108 may include buffers to decouple

5   chip 102 from relatively slow peripherals and to allow the

peripherals to operate asynchronously. PCI bridge 108 may be

coupled to external devices through controller 122 over PCI

bus 124. These external devices may be input devices such as

keyboard 116, mouse 118, and modem 120.

10   Chip 110 may be an integrated circuit that is similar to

chip 102. Chip 102 may include bus interface unit (BIU) 126

and test controller 128. BIU 126 may operate as an

input/output port to ~~communicated~~ *Communicate* signals between processor

bus 112 and chip 102. Test controller 128 may be any device

15   that asserts test instructions to design for test (DFT)

features, where DFT may be design and hardware features

incorporated into chip 102 to aid in manufacturing and

debugging.

        Also coupled to platform 100 may be tester 130. Tester

20   130 may be a VLSI tester that communicates test instructions

to test controller 128 over bus 132. Bus 132 may be thought

of as a test and maintenance bus used as part of the

interface design to access chip 102. Institute of Electrical

and Electronics Engineers (IEEE) standard 1149.1, entitled

25   Test Access Port and Boundary-Scan Architecture, is an

internationally recognized design standard specifying product

design and test protocols. Particularly, IEEE 1149.1 ~~may~~ *are*

~~specify the interface design to access~~ a chip for testing

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purposes. In one embodiment, bus 132 meets the five-pin

requirement of IEEE standard 1149.1. Moreover, under IEEE

1149.1, a test access port (TAP) may be an example of test

controller 128.

5   **Figure 2** illustrates chip 200. Chip 200 may include

logic units 202, 204, 206, 208, 210, and 212, each of which

may deal with basic operations of a computer system. For

example, logic unit 202 may be a floating point unit (FPU),

logic unit 204 may be an arithmetic logic unit (ALU), and

10   logic 212 may be a memory logic. Each logic unit may be

coupled to bus interface unit 214 through logic unit

controllers 216, 218, 220, 222, 224, and 226 as shown. These

controllers local to the logic units of chip 200 may be

positioned very close to their respective logic unit.

15   Moreover, bus interface unit (BIU) 214 may be similar to BIU

126 of **Figure 1**.

Clock generator 227 may be a ~~core clock~~ _Core Clock Generator_ that is

connected between each logic unit controller and BIU 214.

Clock ~~Clock or clock~~ generator 227 may produce a signal that may be

20   distributed over clock lines within chip 200 in a tree like

structure to the logic units 202, 204, 206, 208, 210, and

212. Each clock signal of a given clock pulse may need to

reach its destination within a timing window for events

within chip 200 to be synchronized. Timing skew may be

25   ~~thought of the~~ _though of as the_ variation between the arrival moment of a

first signal as compared to the arrival moment of one or more

other signals at the same or different logic unit.

Controllers may be placed within chip 200 to control this

timing skew. These deskew (DS) ~~controllers may~~ Controllers, for example, may include a whole host of logic elements that aid in receiving, processing, and retransmitting signals such as clock signals ~~and instructions~~ and data instructions to the logic units so as to synchronize the

5   arrival of all instructions to their associated logic unit. In other words, DS controllers may aid in minimizing any timing skew between the signals. Logic unit controllers 216, 218, 220, 222, 224, and 226 may be DS controllers. As will be discussed below, ~~the invention~~ an embodiment of the invention takes advantage of logic

10   unit controllers 216-226 to receive, process, and retransmit testing signals to reduce the number of global test control lines.

Part of producing a working chip includes testing and debugging that chip. Debugging is an attempt to determine

15   the cause of any malfunction symptoms detected by testing. Circuitry may be built into an integrated circuit to assist in the test, maintenance, and support of an assembled circuit. Hardware features, known as design for test (DFT) features, may be incorporated into a chip to aid in testing

20   and debugging.

Each logic unit within chip 200 may be coupled to cells chained together to form a register. For example, logic 208 may be coupled to register 228 having cells 230, 232, 234, and 236. Logic 212 may be coupled to register 238 having

25   cells 240, 242, 244, 246, 248, and 250. Cells 230-236 and 240-250 may be examples of DFT features.

A ~~Chip 200 may additionally include~~ a2 test controller 252 and tester 254. Test controller 252 may be viewed as an

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integrated test controller when residing within chip 200.
Included within test controller 252 may be an instruction
register (IR) and a test access port finite state machine
(TAP FSM) as described in IEEE 1149.1. Test controller 252
5   and tester 254 may be similar to test controller 128 and
tester 130 of **Figure 1**, respectively.

    Figure 3 illustrates chip 300. Chip 300 may be a
conventional modification of chip 200 of **Figure 2**.
Conventionally, one global test control line is required to
10 run between test controller 252 and a DFT feature for each
type of instruction signal. For example, to transmit a load
signal and a test signal from integrated test controller
(ITC) 252 and register 238 of **Figure 3**, chip 300 may employ
global test control lines 302 and 304, respectively. In a
15 similar way, lines 306 and 308 may run between ITC 252 and
register 228. In other words, for a scanout process, each
DFT feature conventionally may employ two global test control
lines. For a different type of testing process, each design
for test Feature conventionally may employ three, four, five
20 or more global test control lines.

Conventionally, Chips may include, for example,
~~Chips conventionally include~~ fifty to one hundred global
test control lines to transmit information to anywhere from
5,200 DFT features to 49,000 DFT features. These global test
control lines may limit chip designers in the placement and
25 arrangement of the control lines and logical units on chip
300 by taking up valuable space on chip 300. More
restrictively, the timing of the signals distributed by each
of these global test control lines is critical. As noted

below, the invention may reduce the number of global test

control lines to nineteen (for example, one bus having

nineteen lines) to transmit that same information to the

design for test features of a chip.

5   ~~Figure 4~~ *In one embodiment, Figure 4* illustrates chip 400 of the invention. As can

be readily seen, chip 400 may be a modification of chip 200

of **Figure 2**. Included with chip 400 may be internal test

~~bus 402~~ *bus 402 (Global Control line)* disposed between ITC 252 and logic unit controller

226 and internal test bus 404 disposed between ITC 252 and DS

10   controller 222. Chip 400 may also include additional

internal test buses (not shown) disposed between ITC 252 and

each logic unit controller within chip 400.

Each internal test bus (ITB) of chip 400 ~~may be adapted~~ *May pass*

~~to pass~~ test instruction signals as a test instruction packet

15   from ITC 252 to a logic unit controller. Although the bits

of these signals may travel over different lines, these

different lines may be within a single internal test bus

having a single routing path between ITC 252 and a logic unit

controller. Moreover, these test instruction signals may

20   travel according to a clock that is internal to tester 254

rather than the core clock that is internal to chip 400, here

clock 227. For these and other reasons, timing is not

critical with respect to signals routed within an internal

test bus in one embodiment of the invention.

25   To transmit a test information packet in parallel, each

internal test bus of chip 400 may include n number of lines

such that

$$n = a + \log_2 i \qquad\qquad (500)$$

where

n = number of lines,

a = number of ancillary transmission bits, and

$\log_2 i$ = number of instruction bits.

5   Ancillary transmission bits may be those supporting bits

that may be needed to accompany the instruction bits. For a

given distributed test control architecture compliant with

IEEE 1149.1, the number of ancillary transmission bits may be

a constant. The number of instruction bits ($\log_2 i$) may be

10   thought of as a bit stream of zeros and ones. Moreover, the

number of instruction bits ($\log_2 i$) may represent the number of

unique testing tasks that are desired to be performed within

the collective of logic unit controllers (e.g., 222 and 226)

of chip 400. For example, where the number of instruction

15   bits equals eight (8 = $\log_2 256$), the test instruction packet

may include up to two hundred and fifty six (256) unique

testing task signals. The instruction bits may be disposed

within an IEEE 1149.1 Compliant instruction register.

In one embodiment, the information transmitted over

20   internal test bus 402 may include a shift signal and a load

signal. In another embodiment, the information transmitted

over internal test bus 402 may be a clock signal

and the following five components representing eighteen bits:

(i) instruction register contents (8 bits);

25   (ii) partially encoded, relevant states of a test access

port finite state machine (TAP FSM) (4 bits);

(iii) security-bit (1 bit);

(iv) test data input (TDI) (1 bit); and

(v) counter value from a Wave Shaper (4 bits).

Component (i) may be thought of the number of instruction bits (log_2i) and components (ii), (iii), (iv), and (v) may be thought of as ancillary transmission bits (a).

5   Accordingly, from equation 500 above,

$$19 = (1+4+1+1+4) + log_2256 \qquad (500).$$

These nineteen bits of information may travel as a test information packet. Where the ~~test instruction~~ *test information instruction* packet is encoded, the logic unit controller may include components

10   that decode the test instruction packet.

Not all the states of the test access port finite state machine (TAP FSM) need be transmitted over a test bus (402, 404) of chip 400. This may be true where the state in question is not relevant to control DFT logic internal to

15   chip 400. In one embodiment, the relevant states of TAP FSM under IEEE 1149.1 include the following six states: test-logic-reset (tlr), run-test/idle (rti), capture-down register (capDR), shift-DR (shiftDR), update-DR (updtDR),and dead (the remaining eleven states). Accordingly, in one embodiment of

20   the invention, a subset of all the states of a test access port finite state machine are encoded into three bits. In another embodiment, individual bits may be allocated for test-logic-reset (tlr) and run-test/idle (rti) and the residual (remainder) states (capDR, shiftDR, updtDR, and

25   dead) are allocated among two bits.

On receiving a test instruction packet, a logic unit controller may locally generate whatever testing signals are needed for the desired testing operation. For example, on

receiving a test instruction packet having a shift signal and
a load signal, logic unit controller 226 may process the test
instruction packet to locally generate a shift signal and a
load signal. Logic unit controller 226 may then pass these

5   two signals to register 238 over the relatively short
distance of distributed test line 406 and distributed test
line 408, respectively.

Under the conventional method of **Figure 3**, a shift
signal and a load signal each travel separately over its own

10   global test control line between the ITC 252 and register
238. The independent travel of these and other test signals
over a relatively great distance requires tight or critical
control over the timing of these signals. In contrast, one
embodiment of the invention transmits these ~~signals as~~ *signals together* as an

15   instruction bundle or packet between the ITC 252 and logic
unit controller 226 so as to eliminate the number of global
test control lines and the requirement for critical timing.

One embodiment of the invention may be employed as a
method to control at least one DFT feature, such as register

20   238 of **Figure 4**. A test information packet may first be
generated in a test controller of an integrated circuit. The
test information packet may then be transmitted to at least
one logic unit controller over a test bus coupled between the
test controller and the at least one logic unit controller.

25   The test information packet may then be processed within the
at least one logic unit controller to generate at least one
test control signal. The at least one test control signal
may be transmitted to the at least one DFT feature coupled to

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the logic unit controller. A logic unit coupled to the at

least one DFT feature may be interacted with based on the at

least one test control signal.

In another embodiment, a single speed critical global

5   control signal and two locally generated control signals are

used for debug and testability. The two local control

signals are generated by local controllers, and are not speed

critical. Therefore, a partially-distributed control scheme

is formed. This is due to having two signals that are local

10   (distributed control), and one signal that is global. As was

presented above, conventionally two global signals are used

for debug and testability.

Since a snapshot and shift instruction are

conventionally handled as part of a single instruction, the

15   timing of the two global control signals conventionally is

very time critical and a close timing tolerance is necessary.

In contrast, in one embodiment the snapshot and shift

instructions are partitioned into separate operations.

Therefore, a snapshot can be performed and the results can be

20   shifted out after a period of time. Also, trigger mechanisms

are implemented that improve debugability on an integrated

circuit.

Figure 5 illustrates global view 500 and local view 505

of scanout control. Also illustrated in **Figure 5** is debug

25   unit (DBG) 510, ITC 520, ITB 530, and DS controller 540.

Conventionally, five (5) scanout signals are defined as

follows: SCANOUTRST, SCANOUTLOAD, SCANOUTLOADDBG,

SCANOUTSHIFT and SCANOUTSIG. It should be mentioned that

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SCANOUTLOAD instructions are used for a snapshot.

SCANOUTRST resets the scanout chain by setting both load and shift controls to 0. SCANOUTLOADDBG switches scanout cells to load mode and then waits for trigger from the DBG

5   unit 510 illustrated in **Figure 5**. SCANOUTLOAD switches scanout cells to load mode and a snapshot occurs in Run-test/Idle on a low-to-high transition of TDI. SCANOUTSHIFT switches scanout cells to shift mode and shifts captured data in shift-DR (data register) operation sequence. SCANOUTSIG

10   sets both load and shift controls of scanout cells to 1 and then enables the clock to scanout cells. The TAP controller then enters a Run-test/Idle state and waits until a debug trigger enabled by (functional) code.

Figure 6 illustrates logic equations and details of

15   control line signals scanout_load, scanout_shift, ck, and scanout_ctl. Both scanout_load and scanout_shift signals are generated locally by decoding the corresponding instructions in the DS controllers and ~~distributed~~ distributing to the regional clock drivers (RCD). Both signals have relaxed timing constraints

20   since one global signal, scanout_cntl, is used. The one global scanout_cntl signal is generated in the ITC and is routed as a critical signal (staged in the ITC and the DS controllers) to all the DS controllers. The scanout_cntl signal gates qclk (queue clock) in lbfs (last buffer first

25   serve) that contain scanout cells to generate scanout_clk to the scanout cells. The scanout_cntl signal is a function of the scanout instructions, the TAP FSM state, input from the debug unit (dbgsnapshot when SCANOUTLOAD is used), rising

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transition on TDI (when SCANOUTLOADDBG is used) and TCK (test clock) (for SCANOUTSHIFT).

When SCANOUTLOADDBG is loaded, the trigger input is provided on a debug pin (DP). The debug unit (DBG) is

5   programmable to respond to the trigger input after a variable latency. The DBG triggers a signal (dbgsnapshot) that is an input to the ITC. The ITC in turn triggers the scanout_cntl signal, which causes a snapshot. This feature, programmable debug, is very powerful for debugging purposes.

10   When SCANOUTLOAD is loaded, the trigger input is provided by a low-to-high transition on the TDI pin. This provides an additional model of snapshot that is a failsafe option and is independent of the DBG. **Figure** 7 illustrates scanout clock waveforms for shifting a scanout chain (one

15   shift per clock). **Figure** 8 illustrates scanout clock waveforms for a snapshot on an external trigger.

The distributed test control scheme ~~of the invention~~ in one embodiment of the invention works towards reducing the number of global test control lines, relaxes routing constraints on the test control lines,

20   and adds greater flexibility in the physical placement of the test controller and test control logic. This translates to lower silicon area and reduced design effort (cost, efficiency, quality, reliability, and timeliness). Moreover, the distributed test control scheme of the invention is

25   scalable and flexible; that is to say, the distributed test control scheme may include the ability to add support for new test features late in the design cycle and implement fixes with relatively small impact on schedule.

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The above embodiments can also be stored on a device or medium and read by a machine to perform instructions. The device or medium may include a solid state memory device and/or a rotating magnetic or optical disk. The device or

5   medium may be distributed when partitions of instructions have been separated into different machines, such as across an interconnection of computers.

The exemplary embodiments described herein are provided merely to illustrate the principles of the invention and

10   should not be construed as limiting the scope of the subject matter of the terms of the claimed invention. The specification and drawings are, accordingly, to be regarded in an illustrative rather than a restrictive sense. Moreover, the principles of the invention may be applied to

15   achieve the advantages described herein and to achieve other advantages or to satisfy other objectives, as well.